

POLISHING BODY AND RELATED MANUFACTURING METHOD

ABSTRACT

A polishing body formed in a circular disc, has a matrix resin and multiple polishing particles, for use in polishing work in CMP method, the matrix resin including a plurality of interconnected pores containing the polishing particles respectively, and a plurality of interconnected pores and the matrix resin with a cross sectional area of the large-size pore in one cross section greater than that of the interconnected pore.

Fig. 1